



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

June 12, 2003

#3/a  
Fukuda  
6/19/03

Applicant(s): Takaomi SUGIHARA et al.

For: SiC-FORMED MATERIAL AND METHOD FOR MANUFACTURING SAME

Serial No.: 09/842 519

Group: 1762

Confirmation No.: 7274

Filed: April 25, 2001

Examiner: Chen

International Application No.: N/A

International Filing Date: N/A

Atty. Docket No.: Fukuda C-34

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action dated March 12, 2003,  
please amend the above-identified application as follows:

(Please see following pages.)